



Docket No. 60919 (70551)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: T. Inui et al.

U.S. SERIAL NO: 10/789,085

EXAMINER: M. Song

FILED: February 27, 2004

GROUP: 1722

FOR: CRYSTAL GROWTH APPARATUS AND CRYSTAL GROWTH
METHOD FOR SEMICONDUCTOR THIN FILM

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted by facsimile to the U.S. Patent & Trademark Office by facsimile number 571-273-8300 on January 10, 2007.

By: 

Steven M. Jensen

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

Applicants are in receipt of the Office Action dated October 10, 2006 of the above-referenced application. Please amend the application as follows:

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.